

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/722,644	STEFANI ET AL.	
Examiner	Art Unit	
Jacqueline Cheng	3768	

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
Subclass	Date	Examiner			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
see attached search history	4/24/2007	JC		